

To U.S. Patent and Trademark Office

References for Information Disclosure
Statement

Serial Number: 10/014,290

Filing Date: December 10, 2001

Inventors: Kyoung Il MIN et al.

Examiner: To Be Assigned

Group Art Unit: 2871

Volume 2 of 2

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Sheet 1 of 3

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**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets, if necessary)

Docket Number 404302000800

Application Number 10/014,290

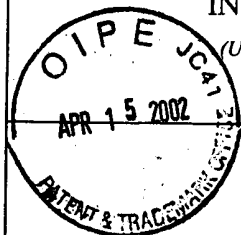
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